

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

10/8 And
10-803
Pw/CH

Applicant(s): Yoo, Woo Sik
Assignee: WaferMasters, Inc.
Title: Gas-Assisted Rapid Thermal Processing
Serial No.: 10/005,827 Filing Date: November 8, 2001
Examiner: Trinh, M. Group Art Unit: 2822
Docket No.: M-11914 US

Irvine, California
June 9, 2003

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P.O. Box 1450
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RESPONSE TO FINAL OFFICE ACTION

Dear Sir:

In response to the Office Action dated April 9, 2003, Applicants submit the following amendments and remarks.

IN THE CLAIMS

The following is a clean version of the entire set of pending claims.

Please cancel Claim 1.

B

2. (Allowed) A system for processing a semiconductor device, the system comprising:
a processing chamber; and
a first plate positioned within said processing chamber and defining a first internal cavity configured to receive a first gas through a first passage into said first internal cavity at a first temperature and to emit said first gas from said first internal cavity at a second temperature through a second passage; and

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Serial No. 10/005,827

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June 9, 2003

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Re: Applicant(s): Woo Sik Yoo
Assignee: WaferMasters, Inc.
Title: Gas-Assisted Rapid Thermal Processing
Serial No.: 10/005,827
Examiner: Judith Cothorn Filed: November 8, 2001
Docket No.: M-11914 US Group Art Unit: 2822

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

Transmitted herewith are the following documents:

- (1) Certification of Facsimile Transmission;
- (2) This Transmittal Letter (in duplicate);
- (3) Response to Final Office Action (3 pages).

1

No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED

<u>Claims Remaining After Amendment</u>		<u>Highest No. Previously Paid For</u>		<u>Present Extra</u>	<u>Rate</u>	<u>Additional Fee</u>
Total Claims	8	Minus	20	= 0	x \$9.00	\$ 0
Independent Claims	2	Minus	4	= 0	x \$42.00	\$ 0
<input type="checkbox"/> Fee of _____ for the first filing of one or more multiple dependent claims per application						\$
<input type="checkbox"/> Fee for Request for Extension of Time						\$

Total additional fee for this Amendment:

- Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.
- Please charge our Deposit Account No. 50-2257 in the amount of
- Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 50-2257

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Certification of Facsimile Transmission

I hereby certify that this paper is being facsimile transmitted to
the U.S. Patent and Trademark Office on the date shown below.


Sandy Kim

June 09, 2003

Respectfully submitted,

Theodore P. Lopez
Attorney for Applicants
Reg. No. 44,881

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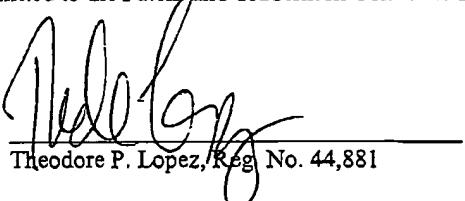
Irvine, California
June 9, 2003

Fax No.: 1-703-308-7724
Attention: Examiner M. Trinh

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following Response to Final Office Action (3 pages) including a Transmittal Letter are being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Dated: June 9, 2003


Theodore P. Lopez, Reg. No. 44,881

Number of pages (including this sheet): 5

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Date:	October 7, 2003		308-7382
To:	Examiner M. Trinh	Fax Telephone #:	703-308-7722
		Office Telephone #:	
From:	Theodore P. Lopez	Date Sent:	
Subject:	Response to Final Office Action	Time Sent:	
Client/File:	M-11914 US	Fax Operator:	

This transmittal consists of 6 total page(s), including this cover sheet.

Message:

Examiner Trinh:

Attached is another copy of the Response to Final Office Action originally filed via facsimile on June 9, 2003.

Please let me know if you have any questions.

If you do not receive all pages, please call (949) 752-7040

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